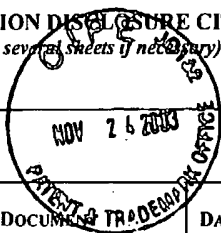


INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)	Docket Number (Optional) SCP-9410		Application Number 10/620,895
	Applicant(s) Akshey Seghal		
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BSC	*AB	5,013,366	05/07/1991	Jackson et al.	134	1	12/07/1988
BSC	AC	5,068,040	11/26/1991	Jackson	218	748	04/03/1989
BSC	*AD	5,313,965	05/24/1994	Palen	134	61	06/01/1992
BSC	AE	5,337,446	08/16/1994	Smith et al.	15	21.1	10/27/1992
BSC	AF	5,355,901	10/18/1994	Mielnik et al.	134	105	10/27/1992
BSC	*AG	5,377,705	01/03/1995	Smith, Jr. et al.	134	95.3	09/16/1993
BSC	*AH	5,401,322	03/28/1995	Marshall	134	13	06/30/1992
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BSC	AJ	5,522,938	06/04/1996	O'Brien	134	1	08/08/1994
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BSC	*AM	5,721,204	02/24/1998	Maxwell et a.	510	206	02/29/1996
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BSC	*AO	5,868,856	02/09/1999	Douglas et al.	134	2	07/23/1997
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BSC	AQ	5,873,948	02/23/1999	Kim	134	19	06/24/1997
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BSC	*AT	5,976,264	11/02/1999	McCullough et al.	134	2	11/30/1998
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							YES	NO
BSC	BC	WO 01/33613 A2	05/10/2001	PCT	H01L	21/00		

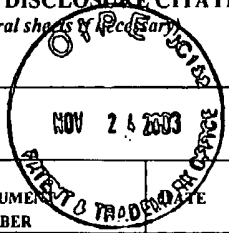
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BSC	*BD	S.B. Williams et al., "Elimination of Solvents and Waste by Using Supercritical Carbon Dioxide in Precision Cleaning," <i>Los Alamos National Laboratory LA-UR-94-3313 (1017)</i> , October 1996, 25 pages in length.
BSC	*BE	S. Verhaverbeke, "Photoresist Stripping With/Without O ₃ Assist," <i>CFM Tech</i> , in <i>Uses of Ozone in the Semiconductor Industry, 19th Annual Semiconductor Pure Water and Chemical Conference</i> , March 13, 2000, 10 pages in length.
BSC	*BF	S. Ojima et al., "Photoresist Stripping Technology Utilizing Water Vapor," <i>2000 Semiconductor Pure Water and Chemical Conference</i> , 2000, pp. 387-398.

Examiner	Date Considered <u>6/29/04</u>
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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	BH	6,500,605	12/31/2002	Mullee et al.	430	329	10/25/2000
	BI	6,508,887	01/21/2003	Park et al.	134	2	11/21/2000
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							YES	NO

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Examiner <i>S. Call</i>	Date Considered 6/28/04
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SCP-9410

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Applicant(s)

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<i>ASC</i>	CA	6,040,284	03/21/2000	Marquis et al.	510	201	05/22/1998
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	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
<i>BS</i>	CC	WO 02/03143 A2	01/10/2002	PCT	G03F	7/42		

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Examiner	<i>S. Call</i>	Date Considered	<i>6/24/04</i>
Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.			